## Supporting Information

## Deformation Mechanism of Poly(3-alkylthiophene) Studied by *in Situ* X-ray

## **Scattering and Texture Analysis**

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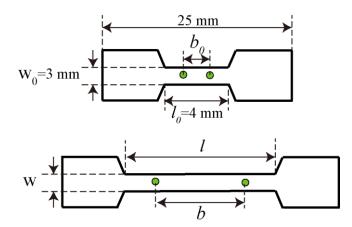


Figure S1. The dimension and marker points (green circles) on the surface of mini tensile bar before and after stretching.

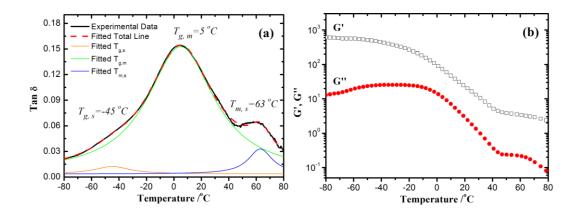


Figure S2. The (a) tan δ and (b) storage modulus (G'), loss storage (G'') of P3DDT film obtained from dynamic mechanical analysis (DMA) measurement. DMA was carried out with a TA Q800 instrument employing uniaxial tension mode. The temperature scan rate was 3 °C/min and the scan range was -100 °C ~ 100 °C. The dimension of the specimen was 11.90 mm × 5.92 mm × 0.06 mm (length × width × thickness). The frequency was fixed at 1 Hz. A strain of 0.1 % was chosen which was located in the linear viscoelastic regime.

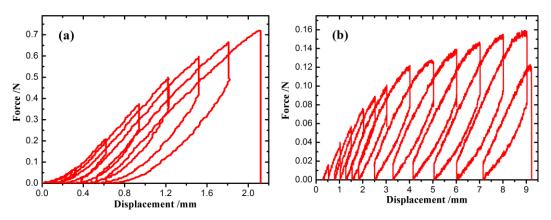
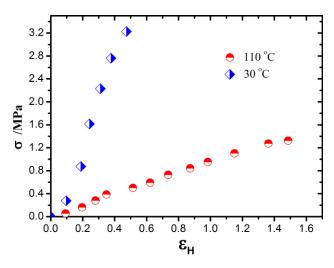
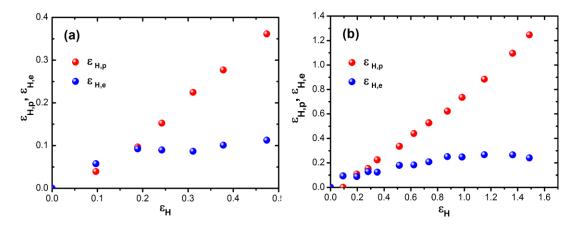


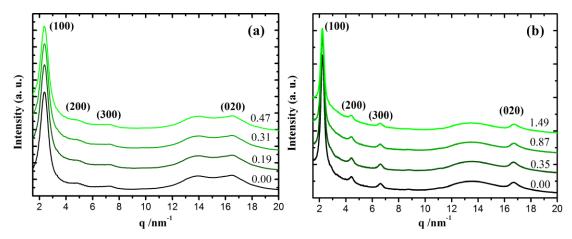
Figure S3. Force-displacement curves of the step-cycle measurements of P3DDT at 30  $^{\circ}$ C (a) and 110  $^{\circ}$ C (b), respectively.



**Figure S4**. True stress ( $\sigma$ )-strain ( $\varepsilon_H$ ) plots of P3DDT film at 30 °C and 110 °C, respectively.



**Figure S5.** Elastic ( $\varepsilon_{H,e}$ ) and plastic ( $\varepsilon_{H,p}$ ) strain as a function of total strain ( $\varepsilon_H$ ) of P3DDT at (a) 30 °C and (b) 110 °C, respectively.



**Figure S6**. 1D WAXS intensity profiles of P3DDT upon stretching at 30 °C (a) and 110 °C (b), respectively.

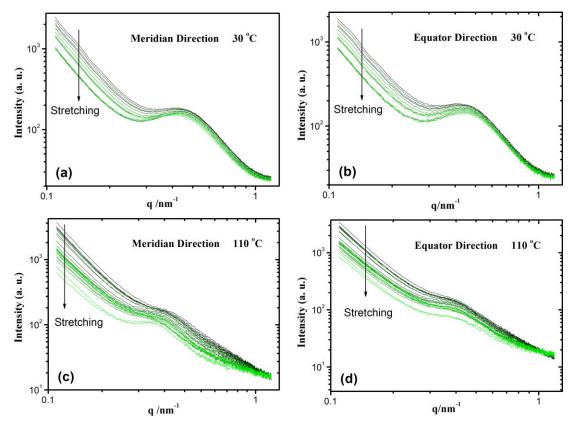


Figure S7. 1D SAXS intensity profiles of P3DDT under uniaxial stretching at 30  $^{\circ}$ C (a)-(b) and 110  $^{\circ}$ C (c)-(d).

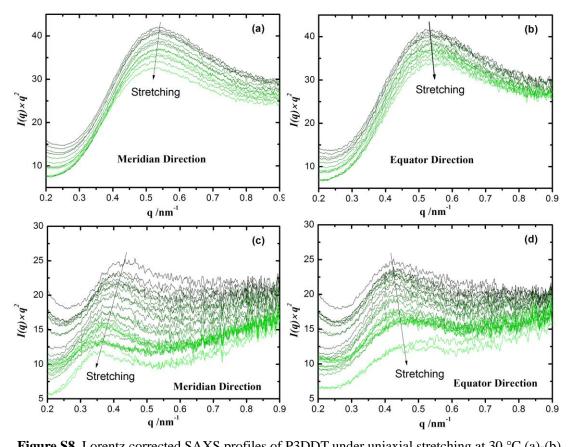
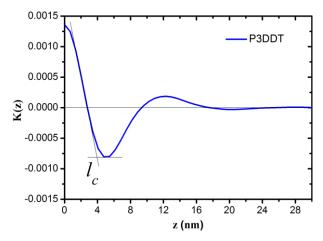
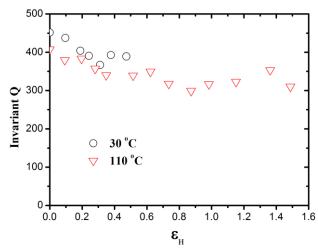


Figure S8. Lorentz corrected SAXS profiles of P3DDT under uniaxial stretching at 30  $^{\circ}$ C (a)-(b) and 110  $^{\circ}$ C (c)-(d).



**Figure S9**. A typical one-dimensional electron density correlation function of unstretched P3DDT at 30 °C.  $l_c$  is crystalline layer thickness, which can be estimated from the correlation function

curve.



**Figure S10.** Scattering Invariant Q as a function of true strain ( $\varepsilon_H$ ) at different temperatures.

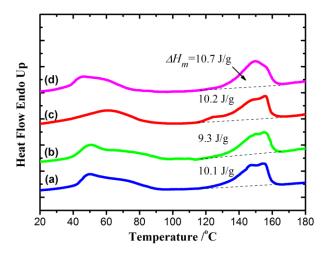


Figure S11. DSC curves of P3DDT before and after stretching. (a) and (c) are annealed at 30 °C and 110 °C for 30 min before stretching, respectively. (b) and (d) are after stretching at 30 °C and 110 °C, respectively. DSC measurements were carried out on a Q2000 DSC (TA Instruments). Temperature scans were performed within the range of 0 °C to 200 °C. Around 4 mg sample were used for measurement. The instrument was calibrated with indium.